

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No. : 10/564,506  
Applicants : Brehm et al.  
Filed : January 12, 2006  
Title : METHOD FOR PRODUCING A  
HIGH RESOLUTION SURFACE  
PATTERN  
TC/A.U. : 2854  
Examiner : Zimmerman, Joshua D.  
Conf. No. : 9411  
Docket No. : 1093-148 PCT/US  
Dated : July 2, 2010

Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

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I hereby certify that this correspondence is being transmitted to the U.S. Patent and Trademark Office via the Office's electronic filing system on July 2, 2010.

Anne C. Arlauskas  
(Printed Name)

Signature: /Anne C. Arlauskas/

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Sir:

In order to fulfill the requirements of candor and good faith set forth in 37 C.F.R. §1.56, Applicants submit herewith the following Supplemental Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §1.97 and §1.98.

**FOREIGN PATENT DOCUMENTS**

<b><u>COUNTRY</u></b>	<b><u>PUBLICATION NO.</u></b>	<b><u>PUBLICATION DATE</u></b>
Japan	JP2000267551	September 29, 2000
Japan	JP1163162 (JP 63-59686)	November 14, 1989

The above-referenced foreign documents are listed on Form PTO/SB/08a. The foreign publications are enclosed to facilitate reference to them.

The above-listed references were cited in a communication from a foreign patent office in a counterpart foreign application less than three (3) months prior to the submission of this Information Disclosure Statement. Accordingly, a copy of the Japanese Office Action is also enclosed.

If the Examiner has any questions or comments relating to the present application, he or she is respectfully invited to contact Applicants' attorney at the telephone number set forth below.

Respectfully submitted,

HOFFMANN & BARON, LLP  
6900 Jericho Turnpike  
Syosset, New York 11791  
(516) 822-3550  
STZ/aca

/steven t zuschlag/  
Steven T. Zuschlag  
Registration No.: 43,309  
Attorney for Applicants